

## STRAPLESS LEAD FRAME

### FIELD OF THE INVENTION

This invention relates to semiconductor devices, and more particularly to a lead frame, used with a heat slug, without tie straps providing for evenly distributive bond wires at the corners of the semiconductor die.

### BACKGROUND OF THE INVENTION

High pin count lead frames have closely spaced inner leads. Lead frames which have tie bars connecting the lead frame to the die pad tend to cause crowding of the lead frame leads and bond wires at the corners of the semiconductor die.

There are several technologies used to reduce the distance between the lead frame inner leads and the integrated circuit bonding pads. One of the most common technologies consists of attaching an interposer between the lead frame inner leads and the semiconductor chip. The interposer is usually made of the same material used in the fabrication of printed circuit boards. The interposer can be made of any material as long as it can be electrically isolated from the lead fingers and is compatible with the physical and mechanical characteristics of the integrated circuit chip and other packaging materials, including lead frames and die attach material. While these procedure tend to strengthen the lead frame leads, and or bond wires, it does not necessarily reduce crowding to the lead frame leads and bond wires connecting the semiconductor die at its corners.

#### **SUMMARY OF THE INVENTION**

The invention is to a strapless lead frame and semiconductor package including a semiconductor die that is rectangular in shape, and a strapless lead frame with the same number of lead frame leads on opposite sides and a different number of lead frame leads on adjacent sides. Lead frame leads extend into the area in which the tie strap would normally be placed. A heat slug is taped to the lead frame to provide a semiconductor die mount area. At least one

lead from one side of the lead frame, located where the tie strap is normally located, is connected via a bond wire to a bond pad on the semiconductor die on a side adjacent to the side where the lead frame lead is located.

The technical advance represented by the invention, as well as the objects thereof, will become apparent from the following description of a preferred embodiment of the invention when considered in conjunction with the accompanying drawings, and the novel features set forth in the appended claims.

#### **BRIEF DESCRIPTION OF THE DRAWINGS**

FIG. 1 shows a prior art lead frame having tie straps connecting the corners of the die mount pad;

FIG. 1a shows a prior art lead frame with a rectangular die pad;

FIG. 2 is a partial view of the lead frame of FIG. 1;

FIG. 3 is a partial view of the lead frame of FIG. 1, the same as FIG. 2, with the tie strap removed;

FIG. 3a is an enlarged view of a portion of FIG. 3 showing the crowding of the bond wires;

FIG. 4 shows the redistribution of lead frame leads and bond wires in the area where the tie bar has been removed; and

FIG. 4a is an enlarged view of a portion of FIG. 4 showing the improvement of bond wire distribution according to the invention.

#### DESCRIPTION OF A PREFERRED EMBODIMENT

FIG. 1 is a prior art lead frame having a plurality of leads 11, a die mount pad 12 and four tie straps 13-16, which are attached to the die mount pad. Lead tips 11a are evenly spaced, but the combination of the corner of the semiconductor device and the bond pads thereon present lead routing problems as described below in FIGS. 3 and 3a.

*subai* → The lead frame of FIG. 1a presents a greater problem in that the semiconductor die to be mounted in the lead frame is rectangular with a greater number of leads on, for example, side a than on smaller size side b.

FIG. 2 is an enlarged partial view of the lead frame of FIG. 1, showing one tie strap 14 and leads 11. The leads 11 adjacent to tie strap 14 have to be bent around tie strap 14. This requires all the leads to be positioned in a smaller space because of the space required by tie strap 14.

FIG. 3 is the same view of lead frame of FIG. 2 with tie strap 14 removed. Semiconductor die 18 is shown with bond pads 19. Bond

pads 19 are attached to lead frame leads 11 with bond wires 17. The bond wires 17 attached to bond pads 19 at positions removed from the semiconductor die corner 18a are fairly evenly spaced. However, the bond wires 17a and 17b are not adequately spaced, with a possible resulting short between the bond wires. This is especially true for the rectangular semiconductor die where bond wires from lead frame leads on one side of the lead frame are connected to bond pads on the adjacent side of the semiconductor die.

FIG. 3a is an enlarged partial view of FIG. 3 showing a portion of the leads 11, bond pads 19 on semiconductor die 18, and bond wires 17. The spacing in this enlarged view FIG. 3a shows the poor spacing between leads 17a and 17b as a result of the tie strap spacing.

FIG. 4 shows a partial view of a lead frame with the tie strap removed, and the leads 20 positioned so that the ends 20a of leads 20 are evenly spaced around the corner of semiconductor die 21. Lead ends 20a are connected to bond pads 22 on semiconductor die 21. The spacing of bond wires 23 is evenly spaced as is the spacing between lead frame lead 20 and bond pads 22.

An advantage of the lead frame without a tie strap is that there is a tooling saving in that there is no need for tooling to cut the tie strap, and the resulting lead frame has a wider lead pitch at the corner of the semiconductor die and lead frame for high pin count packages.

FIG. 4a is an enlarged view of a portion of FIG. 4 clearly showing the improved spacing of the bond wires 23a and 23b. When compared with the spacing of bond wires 17a and 17b of FIG. 3 and FIG. 3a, the improvement of the lead frame leads spacing and the bond wire spacing of the lead frame without the tie strap is clearly seen. Bond wires 23a and 23b are from lead frame leads from one side of the lead frame that extend to bond pads on the adjacent side, or from lead frame leads that are in the space where the tie strap has been removed. As illustrated, leads 23a and 23b would be attached to bond pads on side of semiconductor die 21 if die 21 were square. However, since die 21 is rectangular, leads 23a and 23b extend to side d of die 21. If there were tie bars on the lead frame, this would not be possible since leads 23a and 23b would cross over the tie bar.

Since there are no tie bars to hold a die mount pad in place, in this embodiment, the semiconductor die is supported by a heat

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1970	1971	1972	1973	1974	1975	1976	1977	1978	1979	1980	1981	1982	1983	1984	1985	1986	1987	1988	1989	1990	1991	1992	1993	1994	1995	1996	1997	1998	1999	2000	2001	2002	2003	2004	2005	2006	2007	2008	2009	2010	2011	2012	2013	2014	2015	2016	2017	2018	2019	2020	2021	2022	2023	2024	2025	2026	2027	2028	2029	2030	2031	2032	2033	2034	2035	2036	2037	2038	2039	2040	2041	2042	2043	2044	2045	2046	2047	2048	2049	2050	2051	2052	2053	2054	2055	2056	2057	2058	2059	2060	2061	2062	2063	2064	2065	2066	2067	2068	2069	2070	2071	2072	2073	2074	2075	2076	2077	2078	2079	2080	2081	2082	2083	2084	2085	2086	2087	2088	2089	2090	2091	2092	2093	2094	2095	2096	2097	2098	2099	2100	